

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

SAKAMOTO et al.

Serial No.: 09/449,907

Filed: December 2, 1999



Group: 3723

Examiner D. Nguyen

For: POLISHING CLOTH FOR CHEMICAL MECHANICAL POLISHING, AND
CHEMICAL MECHANICAL POLISHING APPARATUS USING SAID CLOTH

GP 3723
\$
V. Dwyer
#5/Ext. 18
Time
(1 mos)
12-22-00

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
Washington, D.C. 20231

December 18, 2000

RECEIVED
DEC 21 2000
TC 3700 MAIL ROOM

Dear Sir:

Applicants petition the Commissioner of Patents and Trademarks to extend the time for response to the Office Action dated October 17, 2000, for one (1) month from November 17, 2000 to December 17, 2000.

A check in the amount of One Hundred Ten Dollars (\$110.00) to cover the cost of the extension is attached herewith. In the event that any additional fees are required with respect to this paper, please charge our Deposit Account No. 01-2300.

Respectfully submitted,

Arent Fox Kintner Plotkin & Kahn

George E. Oram, Jr.
Attorney for Applicant(s)
Registration No. 27,931

12/20/2000 CCHAU1 00000079 09449907

01 FC:115

110.00 OP

Atty. Docket No. 107176-09004

1050 Connecticut Ave. NW
Suite 600
Washington, D.C. 20036-5339
(202) 857-6000

GEO:sah